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AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Sung-Sok Choi					Docket No. SEC.1140		
Application No. 10/813,439	Filing Date 03/31/2004	Examiner ZERVIGON, RUDY		omer No. 20987	Group Art Uni 1763	Confirmation No.	
APPARATUS AND SYSTEM FOR, AND METHOD OF SUPPLYING PROCESS GAS IN ASSEMICONDUCTOR DEVICE MANUFACTURING EQUIPMENT 14 1000 E							
COMMISSIONER FOR PATENTS: Transmitted herewith is an amendment in the above-identified application.							
The fee has been calculated and is transmitted as shown below.							
	CLAIMS AS AMENDED						
	CLAIMS REMAINING	HIGHEST #	NUMBER EX		RATE	ADDITIONAL	
TOTAL CLAIMS	AFTER AMENDMENT 5 -	PREV. PAID FOR	CLAIMS PRES	SENT	\$50.00	FEE \$0.00	
INDEP. CLAIMS	2 -	3 =	0	x	\$200.00	\$0.00	
Multiple Dependent Claims (check if applicable)						\$0.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$0.00	
No additional fee is required for amendment. □ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. □ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0238 □ Any additional filing fees required under 37 C.F.R. 1.16. □ Any patent application processing fees under 37 CFR 1.17. □ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. □ Dated: NOV. 14, 2006							
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Signature of Pers.					Person Mailing Corr	espondence	

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of : Mail Stop AF

Sung-Sok Choi : Group Art Unit 1763

Serial No. 10/813,439 : Examiner Zervigon, Rudy

Filed March 31, 2004 :

Title: APPARATUS AND SYSTEM FOR, AND METHOD OF SUPPLYING PROCESS GAS IN

SEMICONDUCTOR DEVICE MANUFACTURING EQUIPMENT

AMENDMENT AFTER FINAL

U.S. Patent and Trademark Office Customer Window, Mail Stop AF Randolph Building 401 Dulany Street Alexandria, VA 22314

Sir:

In response to the Office Action dated August 14, 2006, the following amendments and remarks are submitted:

Amendments to the Claims are reflected in the Listing of Claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.